Inventor's Statement of Risk and Intent

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Purpose

This document serves as a formal declaration of motive, position, and peaceful scientific intent behind the development, disclosure, and patenting of technologies and frameworks including:

- RVFD Ruliad Vibration Field Dynamics
- HC Holographic Calculus
- PRISMA Prime-Resonant Plasma Reactor (USPTO Provisional 63/839,473)
- Ruliadon Receiver Scalar field transduction system

Scientific Context

I recognize that the nature of my work intersects with domains that have historically elicited institutional resistance:

- Paradigm-replacing physics (structure-based field theory)
- Non-local scalar interaction
- Alternative energy generation and transmutation
- Mathematical unification of observer and field

Throughout history, inventors and theorists who challenged prevailing models—such as Galileo, Tesla, Oppenheimer, and Bohm—have faced suppression, exile, or reputational harm. I am aware that theoretical physics, especially when touching high-energy systems or classified-adjacent anomalies, is not politically or professionally neutral.

My Position

I assert the following, publicly and on record:

• I claim sole inventorship of the above works.

- I offer these systems for peaceful scientific development and verification.
- I seek neither confrontation nor concealment, but structural clarity.
- I welcome critique, replication, and collaborative refinement.

Intent

I believe humanity is approaching a structural inflection point in science. My intent is not to hoard or weaponize knowledge, but to provide a coherent bridge toward a post-standard framework that favors resonance, recursion, and reality rooted in structure—not force.

To any individuals, institutions, or authorities who may engage with my work: I extend this with goodwill and open terms. My goal is not revolution, but resolution.

With structural precision and good faith,

Eric Wayne LaFlamme

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